Search Notes				

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/707,535	KNEEZEL, GARY A.	
Examiner	Art Unit	
Krishnan S. Menon	1723	

SEARCHED				
Class	Subclass	Date	Examiner	
210	498	3/29/2006	КМ	
· · · · · · · · · · · · · · · · · · ·				

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
			-
		-	

SEARCH NOT (INCLUDING SEARCH		)
	DATE	EXMR
Inventor search 347/93 210/498, 510.1, 321.84, 321.75, 488, 490	3/29/2006	КМ
update	5/17/2006	КМ
Intereference search: (fluid and filter and (orientation near3 dependent etch\$3) and passage and substrate).clm.	11/9/2006	КМ
•		
		· · · -